	Application No.	Applicant(s)
Notice of Allowability	10/814,249	MIZUMURA ET AL.
	Examiner	Art Unit
	Shamim Ahmed	1765
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this a or other appropriate communicat IGHTS. This application is subject	application. If not included ion will be mailed in due course. THIS
2. The allowed claim(s) is/are 1,4,6 and 7.		
3. The drawings filed on <u>01 April 2004</u> are accepted by the E	xaminer.	
4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 6. CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner' Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t 7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	e been received. e been received in Application No. cuments have been received in the of this communication to file a rep MENT of this application. witted. Note the attached EXAMINE es reason(s) why the oath or decla st be submitted. son's Patent Drawing Review (PT s Amendment / Comment or in the 84(c)) should be written on the dra he header according to 37 CFR 1.12 sit of BIOLOGICAL MATERIA	oly complying with the requirements ER'S AMENDMENT or NOTICE OF caration is deficient. CO-948) attached e Office action of wings in the front (not the back) of caration. L must be submitted. Note the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☑ Interview Summa Paper No./Mail [08), 7. ☑ Examiner's Amer	Date <u>8/5/05</u> Indiment/Comment ment of Reasons for Allowance Shamim Ahmed
•	•	Primary Examiner Art Unit: 1765

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Alan E. Schiavelli on 8/5/05.

The application has been amended as follows:

IN THE SPECIFICATION:

At page 1, line 2 in the paragraph of "Cross-Reference to Related application", after the phrase "February 25, 2002," insert "<u>US patent 6,793,833</u>".

IN THE CLAIM:

Cancel the new claims 10-21.

- 2. The following is an examiner's statement of reasons for allowance: The prior art does not teach a process for etching an organic insulating film without using an etching stopper layer including the step of controlling the etching process while keeping the measured value of the light emission spectral intensity ratio CN/H at 1 or less, wherein both the light emission spectral intensity for hydrogen atom and the cyan molecule are measured with respective wavelength as the context of claim 1.
- 3. The closest prior art Fukazawa (JP-2000-252359) discloses a process for etching an organic insulating film including the step of measuring the emission spectrum

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intensity ratio of CN/ H is an opposite value than the claimed ratio as shown in paragraph 0040 and figure 5.

4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Terminal Disclaimer

5. The terminal disclaimer filed on 5/16/05 disclaiming the terminal portion of any patent granted on this application which would extend beyond the expiration date of US patent 6,793,833 has been reviewed and is accepted. The terminal disclaimer has been recorded.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shamim Ahmed whose telephone number is (571) 272-1457. The examiner can normally be reached on M-Thu (7:00-5:30) Every Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shamim Ahmed Primary Examiner Art Unit 1765

SA August 6, 2005